

10/22/01
JC685 U.S. PTO

12-10-01

Docket No. 4097 P01 A

Commissioner of Patents and Trademarks
BOX PATENT APPLICATION
Washington, D.C. 20231

JC675 U.S. PTO
10/007367
10/22/01

Re: Inventor: DANIEL J. HOFFMAN, YAN YE, DAN KATZ, DOUGLAS A. BUCHBERGER, JR., XIAOYE ALLEN ZHAO, KANG-LIE CHIANG, ROBERT B. HAGEN, and MATTHEW L. MILLER
Title: MERIE PLASMA REACTOR WITH OVERHEAD RF ELECTRODE TUNED TO THE PLASMA WITH ARCING SUPPRESSION

Transmitted herewith is the Continuation In Part of U.S. Application Serial No. 09/527,342, Filed on March 17, 2000 including:

Specification, claims and abstract, totaling 70 pages.
 Drawings totaling 10 pages, Formal
 Declaration and Power of Attorney.
 Assignment of the invention to **Applied Materials, Inc.**
 Information Disclosure Statement

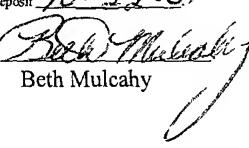
FEE CALCULATION

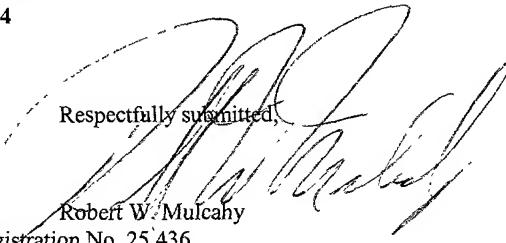
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	30	-20=	10	X\$18.00	\$180.00
Independent Claims	1	-3=	0	X\$78.00	\$000.00
Basic Filing Fee				\$710.00	\$ 710.00
TOTAL FEES					\$ 890.00

The Commissioner is hereby authorized to charge \$ 890.00 to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
 The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
 Please address all future correspondence to:

**PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Department
3050 Bowers Ave., M/S#2061
Santa Clara, CA. 95054**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231
Express Mail Receipt No. EL 867379729 US
Date of Deposit 10-22-01

Signature 
Beth Mulcahy

Respectfully submitted,

Robert W. Mulcahy
Registration No. 25,436
Attorney for Applicant